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Complete if Known

Application Number 10/666,742

Filing Date September 19, 2003

First Named Inventor Wood et al.

Group Art Unit Unknown

Examiner Name Unknown

Attorney Docket Number 6095US (03-0593.00/US)

	Document Number	U.S. PATENT D Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
niger Cite	Number - Kind Code ² (if known)			
/ (,	US- 6,251,488	06/26/01	Miller et al.	
	US- 6,259,962	07/10/01	Gothait	
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		FØREIGN P	ATENT DOCU	MENTS		
Examiner Initials*	Cite No.1	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
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Substitute for form 1449A/PTO Complete if Known Application Number 10/666,742 INFORMATION DISCLOSURE September 19, 2003 Filing Date STATEMENT BY APPLICANT First Named Inventor Wood et al. Group Art Unit Unknown (use as many sheets as necessary) Examiner Name Unknown 6095US (03-0593 00/US) Attomey Docket Number

		OTHER PRIOR ART NON PATENT LITERATURE DOCUMENTS	
Examiner Initiáls *	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	
AR		U.S. Patent Application Publication No. 2002/0171177 A1 to Kritchman et al., dated November 21, 2002	
		U.S. Patent Application Publication No. 2003/0151167 A1 to Kritchman et al., dated August 14, 2003	
		U. S. Patent Application Publication No. 2003/0176021 A1 to Grigg, dated September 18, 2003	
		MILLER et al., "Maskless Mesoscale Materials Deposition", Deposition Technology, September 2001, pages 20-22	
		MILLER, "New Laser-Directed Deposition Technology", Microelectronic Fabrication, August 2001, page 16	
		Webpage, Objet Prototyping the Future, Objet FullCure700 Series, 1 page	
		Webpage, Objet Prototyping the Future, How it Works, 2 pages	
		U.S. Patent Application No. 09/512,203, filed February 24, 2000, entitled "Tape Stiffenner, Semiconductor Device Component Assmeblies Including Same, and Stereolithographic Methods for Fabricating Same", inventor Ford B. Grigg	
AC		U.S. Patent Application No. 10/666,930, filed September 19, 2003, entitled "Method and Apparatus for Supporting Wafers For Die Singulation and Subsequent Handling", inventor Farnworth et al.	

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Form PTO-1449 Docket Number (Optional) **Application Number** 6095US (03-0593.00/US) N t Yet Assign d **INFORMATION DISCLOSURE CITATION** Applicant Wood tal. IN AN APPLICATION (Use several sheets if necessary) Filing Date S ptember 19, 2003 Group Art Unit Unknown **U.S. PATENT DOCUMENTS** DOCUMENT NUMBER EXAMINER FILING DATE IF APPROPRIATE DATE NAME CLASS SUBCLASS ÎTIAL 08/24/1976 3.976.288 Cuomo, Jr. 4,925,515 05/15/1990 Yoshimura et al. 5,460,703 10/24/1995 Nulman et al. 5,705,016 01/06/1998 Senoo et al. 6,039,830 03/21/2000 Park et al. 6,150,240 11/21/2000 Lee et al. 6,245,646 B1 06/12/2001 Roberts 6,344,402 B1 02/05/2002 Sekiya 6,498,074 B2 12/24/2002 Siniaguine et al. FOREIGN PATENT DOCUMENTS Translation DOCUMENT DATE COUNTRY CLASS SUBCLASS NUMBER YES NO OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) U.S. Patent Application Serial No. 10/094,161, filed March 6, 2002, for "Encapsulated Semiconductor Components and Methods of Fabrication." بال Ja **EXAMINER** DATE CONSIDERED whether or not citation is in conformance with MPEP § 609; Draw line through citation if EXAMINER: Initial if citation consid red not in conformance and not considered Include copy of this form with n xt communication to the applicant.